

Report of visit at IAP

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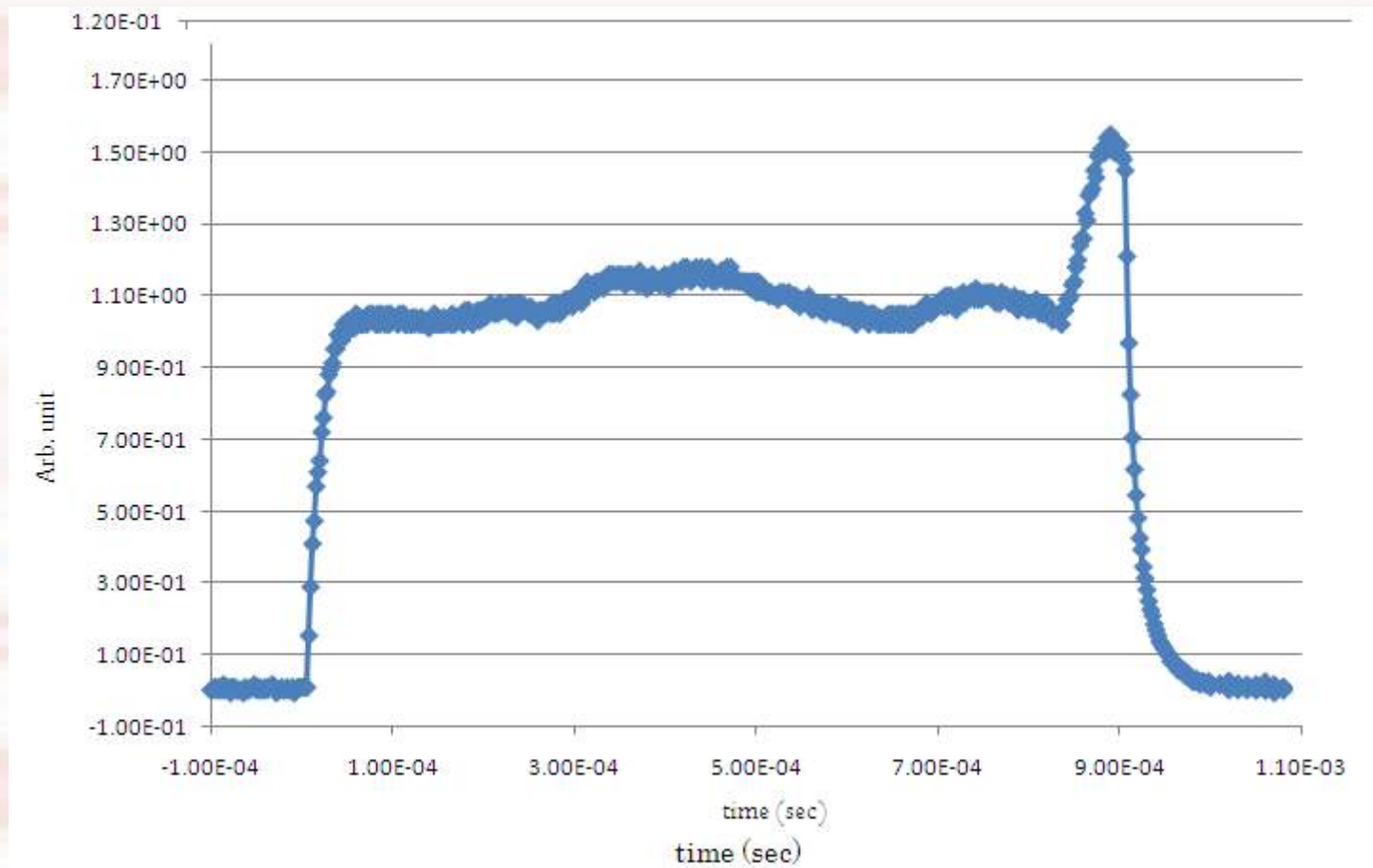
Picosecond Master Oscillator

- ◆ LD pumped Yb fiber oscillator
- ◆ 1047nm
- ◆ 40.625 Mhz repetition (1300/5).

Macro Pulse Profiler+YFPA

- ◆ Reduce the repetition rate from 40.625 -> 2.708MHz (1300/480) by AOM.
- ◆ Pre-amplification by Yb fibre, 0.3nJ/pulse
- ◆ Macro-pulse duration is 0.9ms (fixed).
- ◆ Macro-pulse envelope modulation to compensate the gain in-uniformity.
- ◆ 2.0mW average power (0.05nJ/pulse)

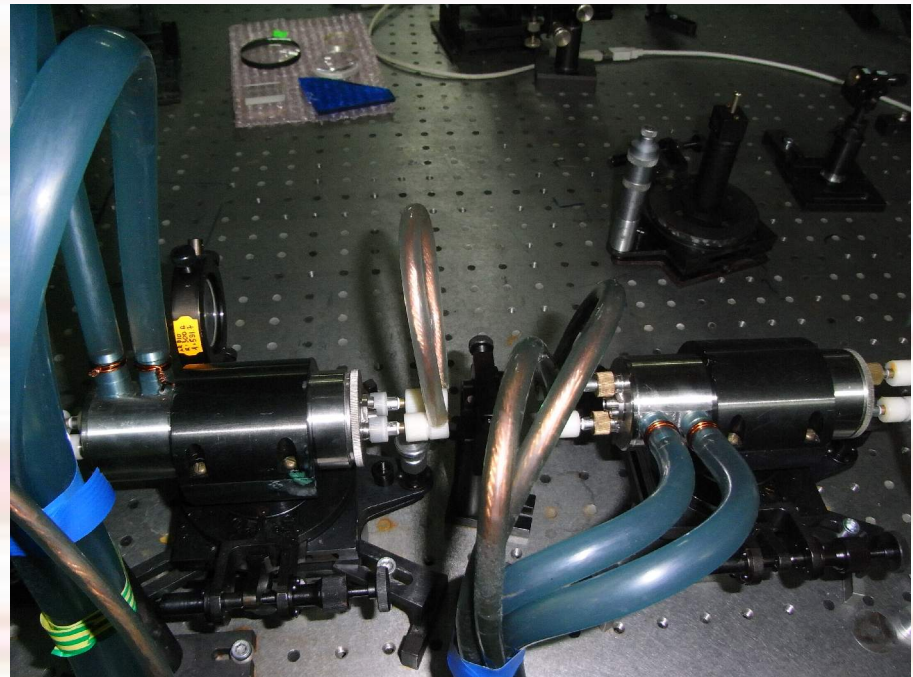
Output of MPP



No modulation

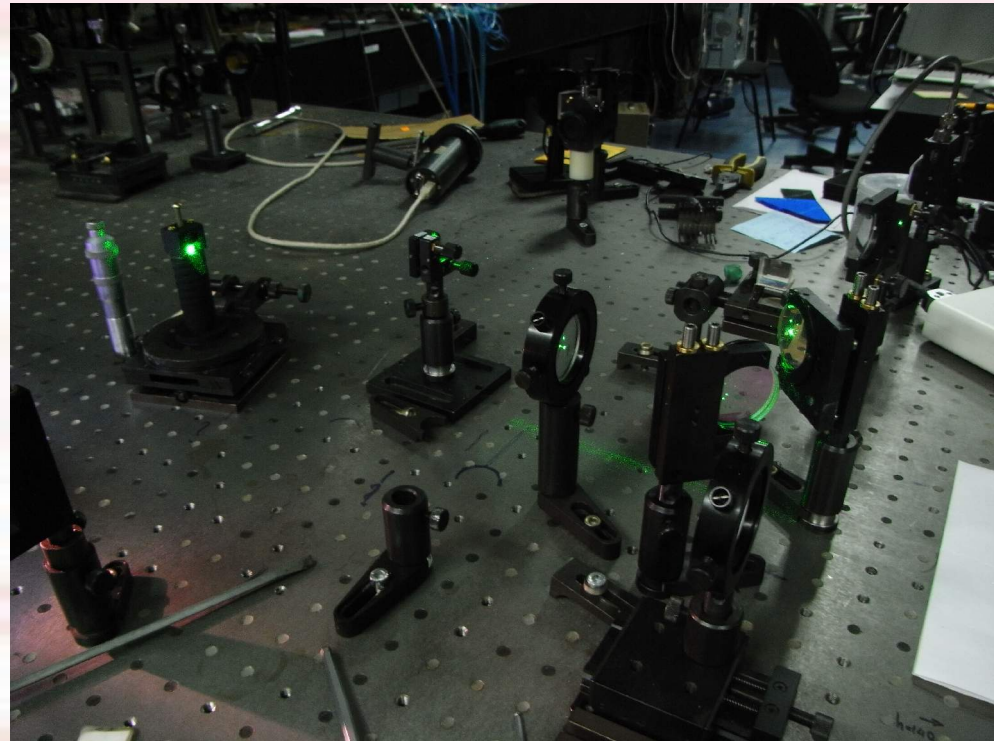
Nd:YLF Amplifier

- ◆ 2 double-pass Nd:YLF amplifiers pumped by flush-lamps.
- ◆ 140mW average power in macro-pulse, 30 μ J/pulse @1047nm.
- ◆ Micro Pulse duration is 10ps at 1047nm.



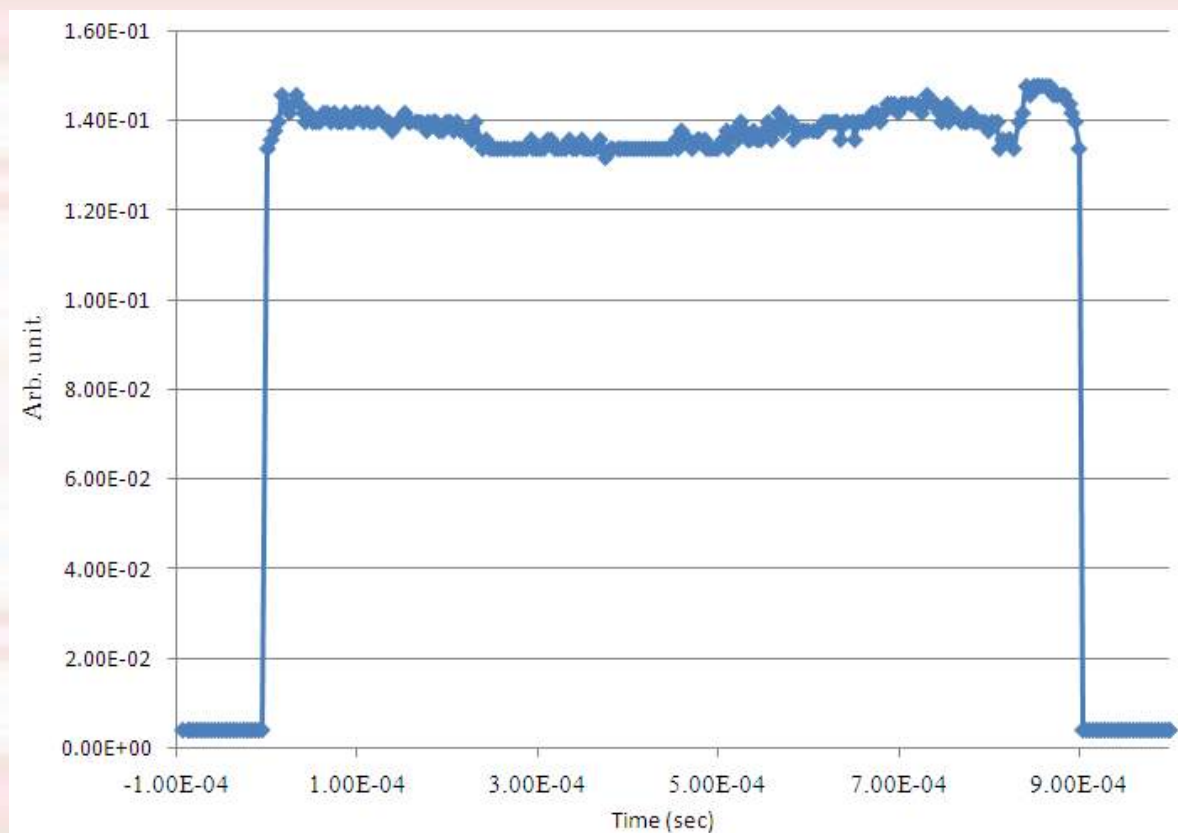
HGs

- ◆ SHG : 7.5mm KTP
 - ◆ 80mW average power, 6.5 μ J/pulse
 - ◆ 8.5ps micro-pulse duration
- ◆ FHG: 10.0mm BBO
 - ◆ 23mW average power, 1.9 μ J/pulse (1.6 μ J/pulse to 3.2nC with 1.0% QE)
 - ◆ 8.0ps micro-pulse duration

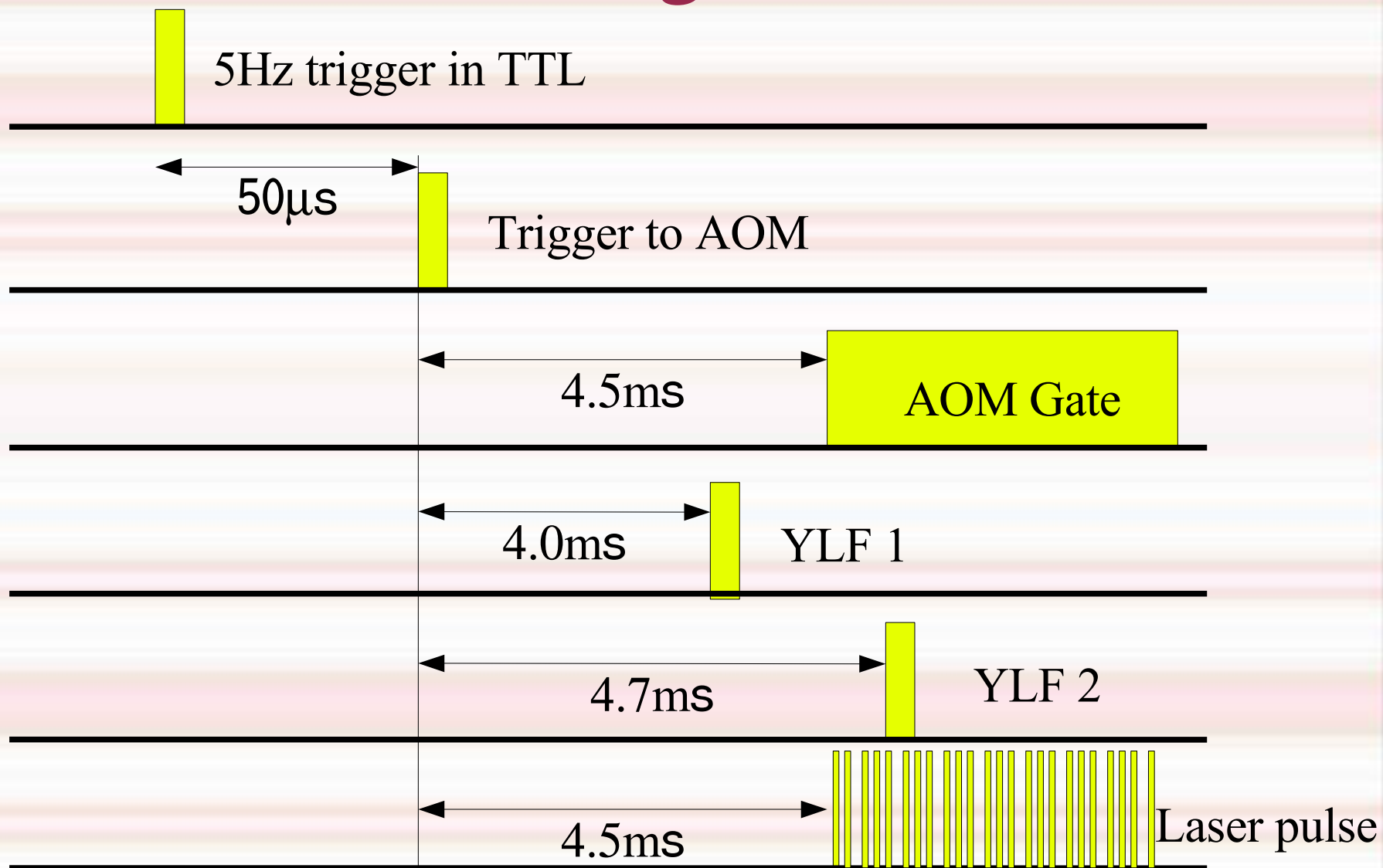


Macro Pulse Uniformity

- ◆ Pulse uniformity in a macro-pulse is found to be around 3% in rms after optimization.
- ◆ Pulse-by-pulse jitter has been observed, but it is not qualified yet.

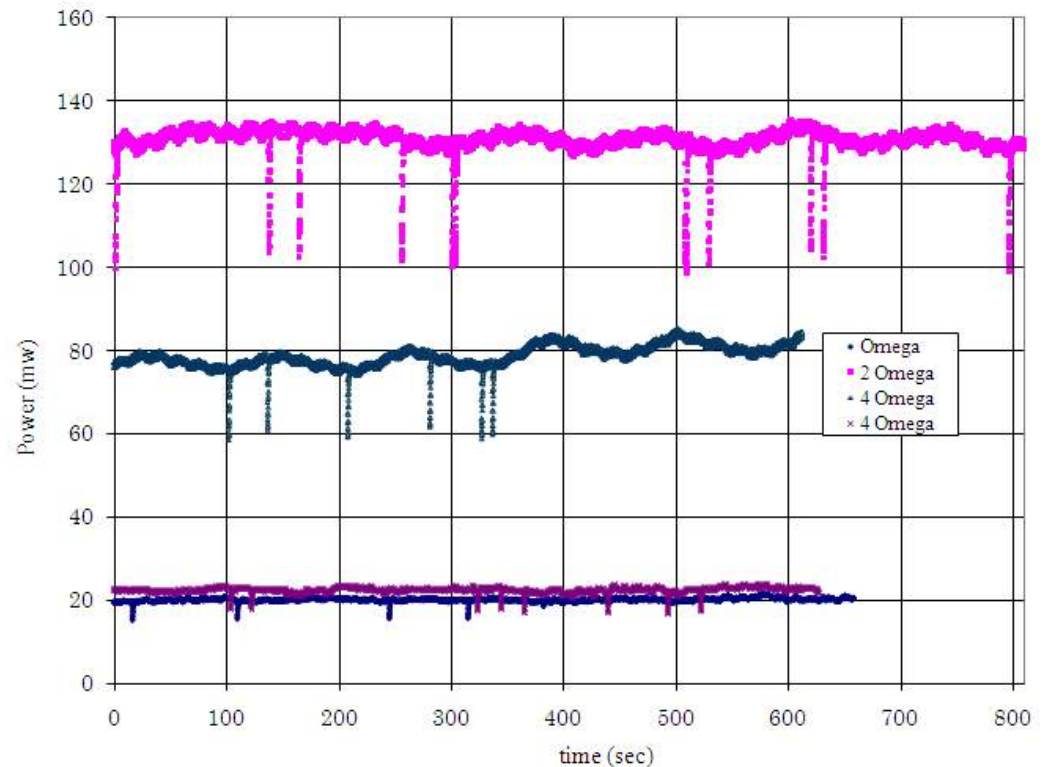


Timing Chart



Stability

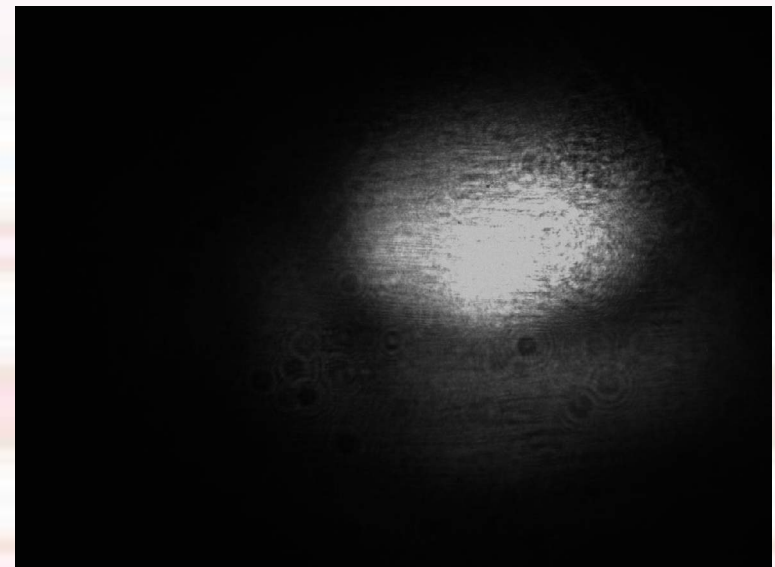
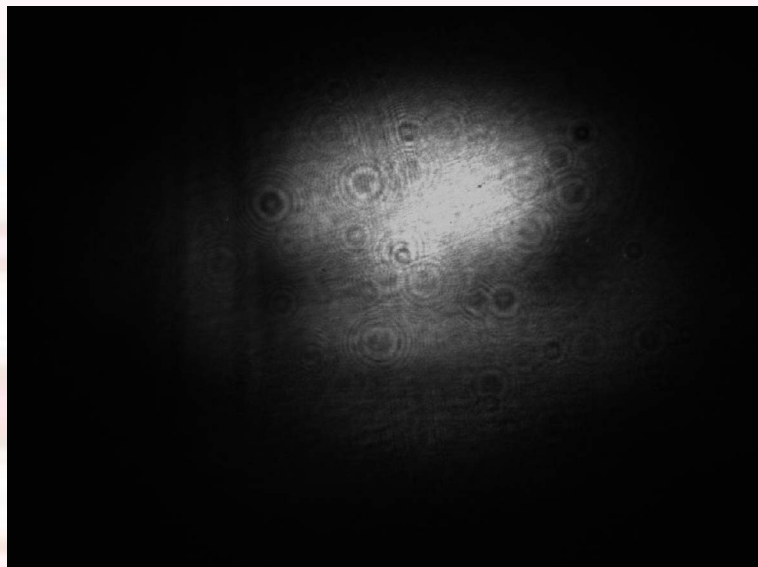
- ◆ Temporal power stability was measured for 1ω , 2ω , and 4ω .
- ◆ 4ω had the best stability and 2ω has the worst stability.
- ◆ The good stability on 4ω is due to the saturation of conversion.



	1ω	2ω	4ω	4ω
Average	131	78.9	22.5	20.1
RMS	3.33	2.8	0.72	0.46
Ratio	2.54%	3.55%	3.20%	2.29%

Laser Spot Profile

- ◆ Laser profile at 4w is observed by CCD camera with attenuation.
- ◆ Pointing stability is not qualified yet.



The system in Operation



Jitter in 4ω



Plan and Procedure

- ◆ February 2010: Transporting to Japan
 - ◆ Less than 1 week for actual transportation.
 - ◆ 1-2 weeks for custom inspection and paper work.
 - ◆ The system is delivered to KEK at the end of February.
- ◆ March 2010
 - ◆ 4 IAP researchers/engineers stays at KEK to implement the system at STF location.

Summary

- ◆ The laser system for STF is developed by IAP under collaboration between JINR and KEK/Hiroshima.
- ◆ The two day investigation confirmed that the required performances are satisfied by the system.
- ◆ The operation training was done during the stay. The sequence of usual operation, macro-pulse uniformity correction, HG crystal adjustment, Flush-lamp exchange procedure, profile measurement, repetition rate adjustment, etc. were exercised.
- ◆ The first task is prepare infrastructures and items to implement the system at KEK-STF.
- ◆ PLL should be implemented to make synchronization to external RF signal.
- ◆ We need several modifications to improve the system usability, e.g. Macro-pulse length adjustment, power adjustment, etc.